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1993 IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the application of:

KONNO et al

Serial No.: 07/743,383

Group Art Unit: 1104

Filed: August 21, 1991

Examiner: G. Goudreau

For: METHOD FOR PRODUCING SEMICONDUCTOR INTEGRATED CIRCUITS AND APPARATUS USED IN SUCH METHOD

AMENDMENT UNDER 37 CFR §1.115

Honorable Commissioner
of Patents and Trademarks
Washington, D.C. 20231

January 7, 1993

Sir:

In response to the official Office Action dated October 5, 1992, please amend the above-identified application as follows:

IN THE SPECIFICATION:

Page 4, line 22, ~~delete "an";~~

line 23, ~~change "microwaves" to --microwave-- and delete "an".~~

Page 5, line 1, ~~change "compound" to --compounds--;~~

line 3, ~~change "compound" to --compounds--;~~

line 20, after "etching,", ~~insert --can-- and change "remains" to --remain--;~~

line 23, ~~delete "an" and change "film" to --films--;~~

line 26, ~~change "contacting" to --being exposed to--.~~

Page 10, line 9, ~~change "is" to --are--.~~

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